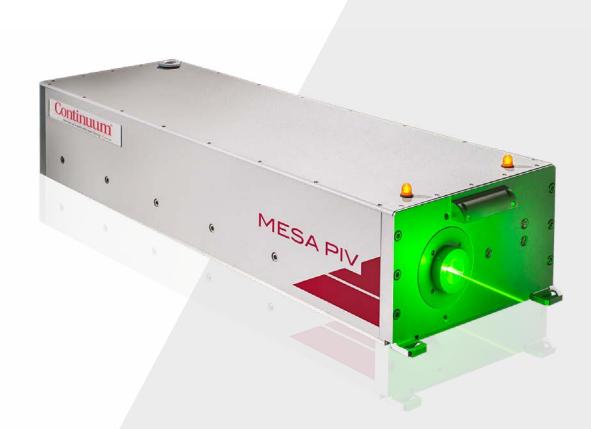
Mesa[™] PIV

High Power Diode Pumped Nd: YAG Laser

Mesa PIV is a dual oscillator/single head, high repetition rate, diodepumped Nd:YAG laser. It offers ultimate flexibility for PIV and other dual output applications.

The combination of two oscillators allows complete control of pulse separation and pulse energy. Both oscillators in the Mesa PIV are identical in optical design giving temporally and spatially matched pulses for the highest degree of cross-correlation. Each oscillator can be independently triggered via TTL inputs. As an option, a compact, external combination box can be directly attached to the laser to make access to the beam combination optics easier and safer for the rest of the laser system.



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Applications

- Industry: > Stent/Glass/PCB/Fine Metal
- Cutting > LCD/Solar Edge Deletion
 - > Marking
- > Wafer Trimming
- > Micro-hole Drilling
- > Ceramics Scribing
- > Fine Wire Stripping
- > Diamond/Gemstone Processing

Science:

- > Ti:Sapphire pumping
- > Particle Image
- Velocimetry (PIV)
- > Combustion Analysis
- > Laser Induced Fluorescence
- > LIDAR
- > Resonance Raman Spectroscopy
- > Chemical Analysis of Macromolecules

Key Features

> Laser Microprobe Analysis

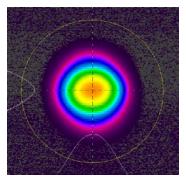
> 18 mJ total energy at 1-6 kHz

- > 120 W average power at 10 kHz
- > Ideal for Particle Image Velocimetry
- > Independent external trigger for each oscillator
- > Compact & rugged package designed for 24/7 operation
- > Record 3 min. diode module replacement with no realignment necessary
- > Proprietary optical cavity design for optimal beam quality



Specifications ¹	532- 120-M	532- 80-M	532- 80-L	532- 60-M
Wavelength		53	2	
Power (W) @ 10 kHz	120	80)	60
Energy per Osc (mJ) at 1- 6 kHz	9	6.	5	5
Total Pulse Energy (mJ) at 1-6kHz	18	13	3	10
Repetition Rate (kHz) ¹		1-3	0	
Pulse-to-Pulse Stability (% RMS)	< 2	2	< 3	< 2
Pulsewidth (ns)	< 150	< 170	< 150	< 190
Beam Pointing Stability (µrad RMS)		< 2	20	
Beam Diameter (mm) ³	5		3	5
Beam Divergence (mrad) ⁴	7		5	7
Beam Quality (M²)	< 2	5	< 15	< 25
Polarization ⁵		Circu	ılar	

¹ All specifications at 6 kHz unless otherwise noted
 ² Single shot to 1 kHz available with external trigger.
 ³ Measured at 13.5% level at output window
 ⁴ Typical measurement (±10%).
 ⁵ Cross-polarization available as option.



Mesa PIV 532-120-M Beam Profile

Optical Head (LxWxH)	812 x 254 x 145 mm (31.9 x 10.0 x 5.6 in)		
Power Supply (LxWxH)	509 x 483 x 221 mm (20.0 x 19.0 x 8.7 in)		
Chiller (LxWxH)	699 x 483 x 492 mm (27.5 x 19.0 x 19.4 in)		
Weight			
Optical Head	31.5 kg (70 lbs)		
Power Supply	27 kg (60 lbs)		
Chiller	65 kg (144 lbs)		
Electrical Service			
Power Supply	Single-phase: 200-240 VAC, 50/60 Hz operating current: 10A, max current: 20A		
Chiller	Single-phase: 230 ±10% VAC, 50/60 Hz operating current: 12A, max current: 20A		
Temperature & Hum	idity		
Temperature & Hum Operating Temperature	idity 15 to 35° C		
Operating Temperature	15 to 35° C		
Operating Temperature Storage Temperature	15 to 35° C -20C to 50° C		
Operating Temperature Storage Temperature Relative Humidity	15 to 35° C -20C to 50° C		
Operating Temperature Storage Temperature Relative Humidity Control Interface	15 to 35° C -20C to 50° C 8-80%, non-condensing		
Operating Temperature Storage Temperature Relative Humidity Control Interface User Interface	15 to 35° C -20C to 50° C 8-80%, non-condensing Full featured front panel control		
Operating Temperature Storage Temperature Relative Humidity Control Interface User Interface Serial Interface	15 to 35° C -20C to 50° C 8-80%, non-condensing Full featured front panel control RS-232		
Operating Temperature Storage Temperature Relative Humidity Control Interface User Interface Serial Interface Rear Connections	15 to 35° C -20C to 50° C 8-80%, non-condensing Full featured front panel control RS-232 External beam enable, external trigger		
Operating Temperature I Storage Temperature I Relative Humidity I Control Interface I User Interface I Serial Interface I Rear Connections I Control Software I	15 to 35° C -20C to 50° C 8-80%, non-condensing Full featured front panel control RS-232 External beam enable, external trigger		

Mesa PIV Physical Layout All dimensions are in inches (mm).

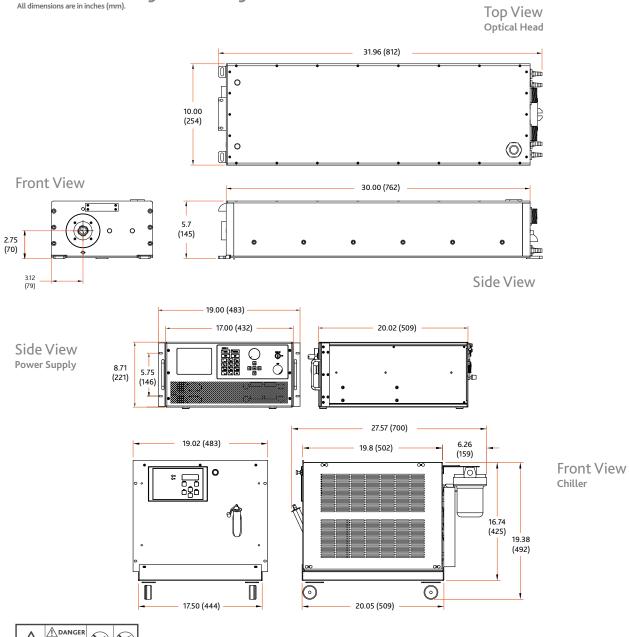
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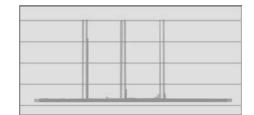
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LASER

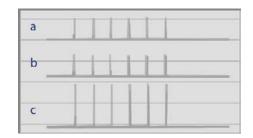
AVOID EYE OR SKIN EXPOSURE TO DIRECT OR SCATTERED RADIATION



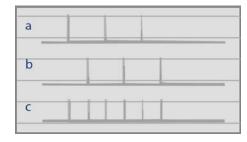
Advantages Generation of Pulse Pairs



Generation of Pulse Pairs Flexible time delay adjustment



Two laser output synchronized to double the pulse energy and peak power, a) one laser output, b) a second laser output, and c) combined output.



Two laser output combined with an adjustable delay to double the repetition rate of the pulse. a) one laser output, b) a second laser output with delay, and c) combined laser output.



Diode pumped Nd:YAG laser

